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CONFIRMATION NO. 1743

<b>SERIAL NUMBER</b> 10/826,823	<b>FILING OR 371(c) DATE</b> 04/15/2004 <b>RULE</b>	<b>CLASS</b> 355	<b>GROUP ART UNIT</b> 2862	<b>ATTORNEY DOCKET NO.</b> (Z)98003 PUS2
<b>APPLICANTS</b> Christian Wagner, Aalen, GERMANY; Michael Trunz, Ellwangen, GERMANY; Ralf Hilgers, Aalen, GERMANY;				
<b>** CONTINUING DATA *****</b> This application is a CON of 09/934,817 08/21/2001 <i>ps</i>				
<b>** FOREIGN APPLICATIONS *****</b> GERMANY 198 07 094.2 02/20/1998 <i>ps</i>				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 06/30/2004</b>				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>D. J. K.</i> Examiner's Signature Initials		<b>STATE OR COUNTRY</b> GERMANY	<b>SHEETS DRAWING</b> 5	<b>TOTAL CLAIMS</b> 46
				<b>INDEPENDENT CLAIMS</b> 8
<b>ADDRESS</b> M. Robert Kestenbaum 11011 Bermuda Dunes NE Albuquerque, NM87111				
<b>TITLE</b> Optical arrangement and projection exposure system for microlithography with passive thermal compensation				
<b>FILING FEE RECEIVED</b> 1668	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	